


<b>INFORMATION DISCLOSURE STATEMENT</b>		Atty Docket: Serial No.: Applicant: Filing Date: Group:		02GR128554494 Not Yet Assigned BOUCHE ET AL. Herewith			
<b>U.S. PATENT DOCUMENTS</b>							
Examiner Initials	Document Number	Date	Name	Class	Sub Class	Filing Date	
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
<b>FOREIGN PATENT DOCUMENTS</b>							
Document Number	Date	Country	Class	Sub Class	Translation		
U/E AK	0907211	4/7/99	EP	H01L35	22		
AL	01/29529	4/26/01	WO	H01L21	302		
U/E AM	1096259	5/2/01	EP	G01P15	08		
AN							
<b>OTHER ART (Including Author, Title, Date, Pertinent Pages, etc.)</b>							
U/E AO	Xiao et al., Silicon/Glass Wafer-to-Wafer Bonding with Ti/Ni Intermediate Bonding, Sensors and Actuators A, Elsevier Sequoia S.A., Lausanne, CH, Vol. 71, No. 1-2, November 1, 1998, Pages 123-126, XP004140083						
U/E AP	Dehé et al., III-V Compound Semiconductor Micromachined Actuators for Long Resonator Tunable Fabry – Pérot Detectors, Sensors and Actuators A, Elsevier Sequoia S.A., Lausanne, CH, Vol. 68, No. 1-3, June 15, 1998, Pages 365-371, XP004139861						
AQ							
<b>EXAMINER:</b> 			<b>DATE CONSIDERED:</b> 2/23/06				

\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.